



Attorney Docket No.: F064

2881
#6/ID8
8/30/02
LW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SERIAL NO.: 09/765,806

ART UNIT: 2881

APPLICANT: Gerlach, et al.

EXAMINER: Not Assigned

FILING DATE: January 19, 2001

TITLE: Shaped and Low Density focused Ion Beams

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Pursuant to the guidelines for Information Disclosure Statements, 37 C.F.R. §§ 1.97-1.98, attached hereto is PTO Form 1449 (one sheet) with references listed for consideration by the Office.

In accordance with 37 C.F.R. § 1.98(a), copies of the listed written references are being provided.

In accordance with 37 C.F.R. §§ 1.97(g)-(h), the filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made or an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

This Information Disclosure Statement is being filed before the mailing of a first Office action on the merits.

Respectfully submitted,

Date: 19 Aug 2002

By: [Signature]

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CERTIFICATE OF MAILING

I hereby certify that this paper or fee is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231, on the 19th day of August, 2002

By: [Signature]

Kathleen Scheinberg